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(Not for submission under 37 CFR 1.99)

Application Number	10564475
Filing Date	2006-07-25
First Named Inventor	GRUDIN, Oleg
Art Unit	3729
Examiner Name	PHAN, Thiem D.
Attorney Docket Number	14836-14US AD/ad

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3	6306718			2009-02-27	SINGH et al.	
4	5252908			1993-10-12	BROKAW	
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	3	J. Babcock, P. Francis, R. Bashir, A. Kabir, D. Shroder, M. Lee, T. Dhayagude, W. Yindeepol, S. Prasad, A. Kalnitskiy, M. Thomas, H. Haggag, K. Egan, A. Bergemont, P. Jansen, "Precision Electrical Trimming of very Low TCR Poly-SiGe Resistors", IEEE Electron. Dev. Letters, vol. 21 (2000), 6, pp.283-285	<input type="checkbox"/>

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